

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yoshitsugu Morita et al.
Serial No. : 10/550,839
International Serial No. : PCT/JP04/04228
International Filing Date : 03/25/2004
Priority Date : 03/25/2003
Confirmation No: 5484
Attny No. : 71,051-020
Title : Semiconductor Device And Method Of Manufacturing Thereof

RESPONSE TO NOTIFICATION OF MISSING REQUIREMENTS
UNDER 35 U.S.C. 371 IN THE UNITED STATES
DESIGNATED/ELECTED OFFICE (DO/EO/US)

Mail Stop BOX PCT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Notification of Missing Requirements Under 35 U.S.C. 371 in the United States Designated/Elected Office (DO/EO/US) dated September 25, 2006, and in compliance with 37 CFR 1.497(a) and (b), identifying the application by the International application number and International Filing date, Applicant is submitting herewith the required Oath or Declaration of the inventors.

Also enclosed herewith is a copy of the Notification of Missing Requirements Under 35 U.S.C. 371 in the United States Designated/Elected Office (DO/EO/US) as requested.

In addition, Applicant is also submitting the required petition fee under 37 CFR 1.17(h) of \$ 130.00. The Commissioner is also hereby authorized to charge any additional fees or credit our deposit account 08-2789 for any overpayments.

**Respectfully submitted,
HOWARD & HOWARD ATTORNEYS, P.C.**

November 13, 2006
Date

/David M. LaPrairie/
David M. LaPrairie, Registration No. 46,295
The Pinehurst Office Center, Suite #101
39400 Woodward Avenue
Bloomfield Hills, MI 48304-5151
(248) 723-0442